



**PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Naoyuki KOBAYASHI et al.

Application No.: 10/588,297

Filed: August 2, 2006

For: EXPOSURE APPARATUS, EXPOSURE METHOD, AND METHOD FOR  
PRODUCING DEVICE



Group Art Unit: 2882

Examiner: M. ASFAW

Docket No.: 128977

**AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In reply to the February 4, 2010 Office Action, the period for reply being extended by  
the attached Petition for Extension of Time, please consider the following:

**Amendments to the Claims** as reflected in the listing of claims; and

**Remarks.**